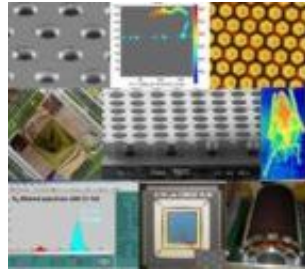


Micro-Pattern Gas Detectors (RD51) Workshop



Contribution ID: 53

Type: **not specified**

Thin layer Amorphous Silicon technology

Friday 18 April 2008 11:20 (20 minutes)

Presenter: WYRSCH, Nicolas (IMT/University of Neuchatel)

Session Classification: MPGD applications II